

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 53080
Shinichi IMAI, et al. : Confirmation Number: 4939
Application No.: 10/619,191 : Group Art Unit: 2125
Filed: July 15, 2003 : Examiner: Maria N. Von Buhr
:

For: SYSTEM AND METHOD FOR MONITORING SEMICONDUCTOR PRODUCTION APPARATUS

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee.

REQUEST TO CONSIDER REFERENCES AFTER CLOSE OF PROSECUTION AND
BEFORE PAYMENT OF ISSUE FEE

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue there from. Please charge the processing fee under 1.17(p) of \$180.00 to Deposit Account .

CERTIFICATION PARAGRAPH

The undersigned certifies that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty
Registration No. 36,139

**Please recognize our Customer No. 53080
as our correspondence address.**

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 MEF:JGH
Facsimile: 202.756.8087
Date: June 14, 2007

INFORMATION DISCLOSURE CITATION IN AN APPLICATION			ATTY. DOCKET NO. 060188-0578	SERIAL NO. 10/619,191		
			APPLICANT Shinichi IMAI, et al.			
(PTO-1449)			FILING DATE July 15, 2003	GROUP 2125		
U.S. PATENT DOCUMENTS						
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ₂ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document		
		US				
		US				
		US				
		US				
		US				
		US				
		US				
		US				
		US				
FOREIGN PATENT DOCUMENTS						
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number 4-Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No
		JP 2002-025981	01/25/2002	Tokyo Electron Ltd	With English abstract	
		JP 2000-252179	09/14/2000	Hitachi Ltd	With English abstract	
		JP 10-135091	05/22/1998	Matsushita Electric Ind. Co. Ltd.	With English abstract	
		JP 2000-198051	07/18/2000	Matsushita Electric Ind. Co. Ltd.	With English abstract	
		JP 2000-252180	09/14/2000	Matsushita electric Ind. Co. Ltd.	With English abstract	
		JP 2002-110493	04/12/2002	Matsushita electric Ind. Co. Ltd.	With English abstract	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)						
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
		Notice of Reasons for Rejection dated May 15, 2007				
EXAMINER			DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

